



<b>INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)</b>			Docket No.: 915-002.014  Applicant(s): Larri VERMOLA  Filing Date: February 15, 2007		Serial No.: 10/577,639  Group:	
<b>U.S. PATENTS</b>						
Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
<b>U.S. PATENT PUBLICATIONS</b>						
Initials	Publication No.	Pub. Date	Name	Class	Sub-class	Filing Date
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<b>FOREIGN PATENT DOCUMENTS</b>						
Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a	
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<b>OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)</b>						
	Korean Office Action dated 8 September 2008 issued in corresponding Korean Patent Application No. 10-2006-7008189 (5 pages)					
	Korean Office Action (English Translation) dated 8 September 2008 issued in corresponding Korean Patent Application No. 10-2006-7008189 (5 pages)					
Examiner's Signature:				Date Considered:		
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